

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akihiko EBINA et al.

Application No.: 10/052,255

Filed: January 23, 2002

Docket No.: 11

111778

For:

METHOD OF MANUFACTURING SEMICONDUCTOR INTEGRATED

CIRCUIT DEVICE INCLUDING NONVOLATILE SEMICONDUCTOR

**MEMORY DEVICES** 

## **SUBMISSION OF ORIGINAL DECLARATION**

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Submitted herewith is the original signed Declaration of the Inventor. This Declaration corresponds to the facsimile copy of the Declaration filed on April 19, 2002.

Respectfully submitted,

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Date: April 26, 2002

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